



TPW

Docket No. 0524-0140.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
Nozawa et al.)
Serial No.: 10/667,823)
Filed: September 22, 2003)
For: Phase Mask Shift Blank, Photo Mask Blank,)
And Manufacturing Apparatus And Method)
Of Blanks)
Examiner: Rodney Glenn McDonald)
Art Unit: 1753)

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Shannon Wallace
Name of applicant, assignee, or Registered Rep.
Shannon Wallace 9/27/05
Signature Date

Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT B

Dear Sir:

In response to the Office Action of May 27, 2005, a one month extension of time being submitted herewith, please amend the above-identified application as follows: